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## Inventor Information for 10/708509

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JS 20070032734 A1	US- PGPUB	20070208		METHOD FOR MONITORING A PHYSIOLOGIC PARAMETER OF PATIENTS WITH CONGESTIVE HEART FAILURE	600/513		Najafi; Nader et al.
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JS 20060169038 A1	US- PGPUB	20060803		FLUID SENSING DEVICE WITH INTEGRATED BYPASS AND PROCESS THEREFOR	73/202		Sparks; Douglas Ray et al.
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20060037187 A1	PGPUB			MAKING A MICROTUBE AND MICROFLUIDIC DEVICES FORMED THEREWITH		73/861.351	Douglas Ray et al.
JS 20060010964 A1	US- PGPUB	20060119		Device and method for sensing rheological properties of a fluid	73/54.01		Sparks; Douglas Ray et al.
JS 20050284815 A1	US- PGPUB	20051229		MEDICAL TREATMENT SYSTEM AND METHOD	210/645	210/646; 210/742; 604/4.01; 604/65	Sparks, Douglas Ray et al.
JS 20050235759 A1	US- PGPUB	20051027		DRUG-SPECIFIC FLUID DELIVERY SYSTEM	73/861.352		Sparks, Douglas Ray et al.
JS 20050126304 A1	US- PGPUB	20050616		FLUID INFUSION METHOD AND SYSTEM THEREFOR	73/861.05		Sparks, Douglas Ray et al.
JS 20050065589 A1	US- PGPUB	20050324		Method and anchor for medical implant placement, and method of anchor manufacture	607/126		Schneider, Richard Lee et al.
JS 20040255648 A1	US- PGPUB	20041223		RESONANT TUBE VISCOSITY SENSING DEVICE	73/54.41		Sparks, Douglas Ray
JS 20040171983 A1	US- PGPUB	20040902		FLUID DELIVERY SYSTEM AND SENSING UNIT THEREFOR	604/65	128/DIG.13	Sparks, Douglas R. et al.
JS 20030159741 A1	US- PGPUB	20030828		FLUID DELIVERY SYSTEM AND METHOD	137/814	604/67	Sparks, Douglas Ray
JS 20030138656 A1	US- PGPUB	20030724		Method of forming a reactive material and article formed thereby	428/615	428/687	Sparks, Douglas Ray
JS 20030121313 A1	US- PGPUB	20030703		Micromachined fluid analysis device and method	73/38		Sparks, Douglas Ray
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JS 20020194908 A1	US- PGPUB	20021226		Integrated microtube sensing device	73/204.26		Sparks, Douglas Ray

JS 20020193818 A1	US- PGPUB	20021219		Process of forming a microneedle and microneedle formed thereby	606/185		Sparks, Douglas Ray
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JS 5719069 A	USPAT	19980217		One-chip integrated sensor process	438/50	148/DIG.135; 438/456; 438/52; 438/53	Sparks; Douglas Ray
JS 5706565 A	USPAT	19980113		Method for making an all-silicon capacitive pressure sensor	29/25.42		Sparks; Douglas Ray et al.
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JS 5531121 A	USPAT	19960702	14	Micromachined integrated pressure sensor with oxide polysilicon cavity sealing	73/716	257/E21.218; 257/E21.573; 73/720; 73/721	Sparks; Douglas R. et al.
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JS 5213999 A	USPAT	19930525		Method of metal filled trench buried contacts	438/639	257/E21.158; 257/E21.295; 257/E21.396; 257/E21.537; 438/386; 438/678; 438/686	Sparks; Douglas R. et al.
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